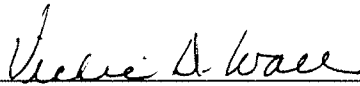


PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

I hereby certify that this correspondence is being electronically filed with the United States Patent and Trademark Office on July 16, 2007 at or before 11:59 p.m. Pacific Time under the Rules of 37 CFR § 1.8.


Vickie D. Wall

Applicant : Nam Hun Kim Confirmation No. 5813
Application No. : 10/593,857
Filed : September 22, 2006
Title : PLASMA CHAMBER HAVING PLASMA SOURCE COIL AND
METHOD FOR ETCHING THE WAFER USING THE SAME

Grp./Div. : 1763
Examiner : To be assigned

Docket No. : 58409/N305

SUBMISSION OF SMALL ENTITY DECLARATION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Post Office Box 7068
Pasadena, CA 91109-7068
July 16, 2007

Commissioner:

Applicant hereby submits the executed Declaration Claiming Small Entity Status for a Small Business Concern for the above-identified patent application. Entry of this Declaration is requested.

Respectfully submitted,

CHRISTIE, PARKER & HALE, LLP



By _____
D. Bruce Prout
Reg. No. 20,958
626/795-9900

DBP/vdw
Enclosure

VDW PAS743963.1-*07/16/07 9:12 AM